

## **PALM INTRANET**

Day: Monday Date: 12/5/2005

Time: 11:43:26

## **Inventor Name Search Result**

Your Search was:

Last Name = SHIMOMURA

First Name = AKIHISA

	Application#	Patent#	Status	Date Filed	Title	Inventor Name
1	10235942	6844523	150	09/06/2002	LASER APPARATUS, LASER IRRADIATION METHOD, MANUFACTURING METHOD FOR A SEMICONDUCTOR DEVICE, SEMICONDUCTOR DEVICE AND ELECTRONIC EQUIPMENT	SHIMOMURA, AKIHISA
	10237172	Not Issued	71	09/09/2002	Laser apparatus, laser irradiation method, semiconductor manufacturing method, semiconductor device, and electronic equipment	SHIMOMURA, AKIHISA
	10252828	Not Issued	93	09/24/2002	LASER IRRADIATION METHOD AND LASER IRRADIATION DEVICE AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE	SHIMOMURA, AKIHISA
	10289219	6962860	150	11/07/2002	A METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE	SHIMOMURA, AKIHISA
	10306345	Not Issued	95	11/29/2002	MANUFACTURING METHOD FOR A SEMICONDUCTOR DEVICE USING A MARKER ON AN AMORPHOUS SEMICONDUCTOR FILM TO SELECTIVELY CRYSTALLIZE A REGION WITH A LASER LIGHT	SHIMOMURA, AKIHISA
	10315204	6764886	150	12/10/2002	MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE	SHIMOMURA, AKIHISA
	10324051	6767799	150		LASER BEAM IRRADIATION METHOD AND METHOD OF	SHIMOMURA, AKIHISA

ĺ				MANUFACTURING A THIN FILM TRANSISTOR	
10330024	Not Issued	41	12/27/2002	Semiconductor device and semiconductor device producing system	SHIMOMURA, AKIHISA
10330025	6933527	150	12/27/2002	SEMICONDICTOR DEVICE AND SEMICONDUCTOR DEVICE PRODUCTION SYSTEM	SHIMOMURA, AKIHISA
10338043	6841797	150	01/08/2003	SEMICONDUCTOR DEVICE AND SEMICONDUCTOR DEVICE PRODUCTION SYSTEM	SHIMOMURA, AKIHISA
10352066	Not Issued	93	01/28/2003	SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME	SHIMOMURA, AKIHISA
10352233	Not Issued	71	01/28/2003	Semiconductor device and method of manufacturing the same	SHIMOMURA, AKIHISA
10352240	Not Issued	93	01/28/2003	SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME	SHIMOMURA, AKIHISA
10395366	6841434	150	03/25/2003	METHOD OF FABRICATING SEMICONDUCTOR DEVICE	SHIMOMURA, AKIHISA
10607542	Not Işsued	61		Method of manufacturing a semiconductor device	SHIMOMURA, AKIHISA
10658472	Not Issued	30		Laser apparatus, laser irradiation method, and manufacturing method of semiconductor device	SHIMOMURA, AKIHISA
10663671	Not Issued	30	09/17/2003	Laser apparatus, laser irradiation method, and manufacturing method of semiconductor device	SHIMOMURA, AKIHISA
10744138	Not Issued	30	12/24/2003	Laser irradiation apparatus, method of irradiating laser light, and method of manufacturing a semiconductor device	SHIMOMURA, AKIHISA
10822005	Not Issued	30	04/12/2004	Laser oscillator	SHIMOMURA, AKIHISA
10871376	Not Issued	30	06/21/2004	Laser irradiation apparatus, laser irradiation method, and method for manufacturing semiconductor device	SHIMOMURA, AKIHISA

10878388	Not Issued	41	06/29/2004	Method for manufacturing a thin film transistor and method for manufacturing a semiconductor device	SHIMOMURA, AKIHISA
10882343	Not Issued	93	07/02/2004	MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE	SHIMOMURA, AKIHISA
10883767	Not Issued	61	07/06/2004	Laser beam irradiation method and method of manufacturing a thin film transistor	SHIMOMURA, AKIHISA ,
<u>10887509</u>	Not Issued	50	07/09/2004	Semiconductor device and method for manufacturing semiconductor device	SHIMOMURA, AKIHISA
10900463	Not Issued	30	07/28/2004	Method for manufacturing semiconductor device, and laser irradiation apparatus	SHIMOMURA, AKIHISA
<u>10914199</u>	Not Issued	41	08/10/2004	Method of manufacturing semiconductor device	SHIMOMURA, AKIHISA
10920316	Not Issued	30	08/18/2004	Method of fabricating semiconductor device	SHIMOMURA, AKIHISA
10935178	Not Issued	30	09/08/2004	Laser oscillator	SHIMOMURA, AKIHISA
10935273	Not Issued	41	09/08/2004	Light-emitting device	SHIMOMURA, AKIHISA
10947133	Not Issued	30	09/23/2004	Light emitting device	SHIMOMURA, AKIHISA
11013539	Not Issued	30	12/17/2004	Semiconductor device and semiconductor device production system	SHIMOMURA, AKIHISA
11087652	Not Issued	30		Semiconductor device and semiconductor device production system	SHIMOMURA, AKIHISA
11150285	Not Issued	30	06/13/2005	Method for manufacturing semiconductor device	SHIMOMURA, AKIHISA

Inventor Search Completed: No Records to Display.

Canah Anathan	Invantar	Last Name	First Name	
Search Another:	inventor	Shimomura	Akihisa	Search

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## **Inventor Name Search Result**

Your Search was:

Last Name = TAKANO First Name = TAMAE

Application#	Patent#	Status	Date Filed	Title	Inventor Name
08997910	6140166	150		METHOD FOR MANUFACTURING SEMICONDUCTOR AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE	TAKANO, TAMAE
<u>09010416</u>	6162704	150	01/21/1998	METHOD OF MAKING SEMICONDUCTOR DEVICE	TAKANO, TAMAE
09034041	6165824	150	03/03/1998	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE	TAKANO, TAMAE
09065692	6133075	150	04/24/1998	SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME	TAKANO, TAMAE
09120244	6432756	150	07/22/1998	SEMICONDUCTOR DEVICE AND FABRICATING METHOD THEREOF	TAKANO, TAMAE
09233771	6201585	150	01/19/1999	ELECTRONIC APPARATUS HAVING THIN FILM TRANSISTORS	TAKANO, TAMAE
09352194	Not Issued	94	07/13/1999	CRYSTALLINE SEMICONDUCTOR THIN FILM, METHOD OF FABRICATING THE SAME, SEMICONDUCTOR DEVICE, AND METHOD OF FABRICATING THE SAME	TAKANO, TAMAE
09352198	Not Issued	161		CRYSTALLINE SEMICONDUCTOR THIN FILM, METHOD OF FABRICATING THE SAME, SEMICONDUCTOR DEVICE, AND METHOD OF FABRICATING THE SAME	TAKANO, TAMAE

09352362	Not Issued	61	07/13/1999	CRYSTALLINE, SEMICONDUCTOR THIN FILM, METHOD OF FABRICATING THE SAME, SEMICONDUCTOR DEVICE, AND METHOD OF FABRICATING THE SAME	TAKANO, TAMAE
09352373	Not Issued	71	07/13/1999	CRYSTALLINE SEMICONDUCTOR THIN FILM; METHOD OF FABRICATING THE SAME, SEMICONDUCTOR DEVICE, AND METHOD OF FABRICATING THE SAME	TAKANO, TAMAE
09369158	6559036	150	08/06/1999	SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME	TAKANO, TAMAE
09532166	6479333	150	03/21/2000	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE	TAKANO, TAMAE
09617105	6524896	150	07/14/2000	SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME	TAKANO, TAMAE
09686652	6627486	150	10/10/2000	METHOD FOR MANUFACTURING SEMICONDUCTOR AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE	TAKANO, TAMAE
09707348	6461943	150	11/06/2000	METHOD OF MAKING SEMICONDUCTOR DEVICE	TAKANO, TAMAE
09874204	6690068	150	06/06/2001	THIN FILM TRANSISTORS AND SEMICONDUCTOR DEVICE	TAKANO, TAMAE
09880089	6828587	150	06/14/2001	SEMICONDUCTOR DEVICE	TAKANO, TAMAE
09882265	6787807	150	06/18/2001	SEMICONDUCTOR DEVICE	TAKANO, TAMAE
09892225	Not Issued	61	11 1	Semiconductor device and fabrication method therefor	TAKANO, TAMAE
09894125	Not Issued	61		Crystalline semiconductor thin film, method of fabricating the same, semiconductor device and method of fabricating the same	TAKANO, TAMAE
09908727	Not	41	07/20/2001	SEMICONDUCTOR DEVICE ·	TAKANO, TAMAE

	Issued			AND METHOD OF MANUFACTURING THE SAME	
09918547	6703265	150	08/01/2001	SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME	TAKANO, TAMAE
10001785	6759313	150	12/05/2001	METHOD OF FABRICATING A SEMICONDUCTOR DEVICE	TAKANO, TAMAE
10056054	6770518	150	01/28/2002	METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE	TAKANO, TAMAE
10078240	6872638	150	02/20/2002	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE	TAKANO, TAMAE
10081767	Not Issued	71	02/25/2002	METHOD OF MANUFACTURING A SEMICONDUCTOR FILM WITH LITTLE WARP	TAKANO, TAMAE
10098153	Not Issued	71	03/15/2002	Process for manufacturing a semiconductor device	TAKANO, TAMAE
10214693	Not Issued	161		Semiconductor device and fabricating method thereof	TAKANO, TAMAE
10265181	Not Issued	41	10/04/2002	Method of making semiconductor device	TAKANO, TAMAE
10357333	6864127	150	02/04/2003	SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME	TAKANO, TAMAE
10370055	6884668	150	02/21/2003	SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREFOR	TAKANO, TAMAE
10607542	Not Issued	61	06/27/2003	Method of manufacturing a semiconductor device	TAKANO, TAMAE
<u>10614110</u>	6908797	150	07/08/2003	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE	TAKANO, TAMAE
10656239	6974732	150	09/08/2003	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE	TAKANO, TAMAE
10658472	Not Issued	30	09/10/2003	Laser apparatus, laser irradiation method, and manufacturing method of semiconductor device	TAKANO, TAMAE
10663671	Not Issued	30	09/17/2003	Laser apparatus, laser irradiation method, and manufacturing method of semiconductor device	TAKANO, TAMAE

10678168	6911698	150	10/06/2003	CRYSTALLINE SEMICONDUCTOR THIN FILM, METHOD OF FABRICATING THE SAME, SEMICONDUCTOR DEVICE, AND METHOD OF FABRICATING THE SAME	TAKANO, TAMAE
10727651	Not Issued	41	12/05/2003	Thin film transistors and semiconductor device	TAKANO, TAMAE
10792132	Not Issued	93	03/04/2004	SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME	TAKANO, TAMAE
10801542	Not Issued	30	03/17/2004	Display device, semiconductor device, and electronic device	TAKANO, TAMAE
10803190	Not Issued	30	03/18/2004	Device substrate, light emitting device and driving method of light emitting device	TAKANO, TAMAE
10834093	6956235	150	04/29/2004	SEMICONDUCTOR DEVICE	TAKANO, TAMAE
10882634	Not Issued	41	07/02/2004	Method of fabricating a semiconductor device	TAKANO, TAMAE
10896906	Not Issued	30	07/23/2004	Method for manufacturing a semiconductor device	TAKANO, TAMAE
11078395	Not Issued	30	03/14/2005	Method of manufacturing a semiconductor device	TAKANO, TAMAE
11089055	Not Issued	30	03/25/2005	Method for manufacturing semiconductor device	TAKANO, TAMAE
11107822	Not Issued	30	1	Semiconductor device and manufacturing method therefor	TAKANO, TAMAE
11119466	Not Issued	20	05/02/2005	Method of manufacturing a semiconductor device	TAKANO, TAMAE
11266369	Not Issued	20	11/04/2005	Crystalline semiconductor thin film, method of fabricating the same, semiconductor device, and method of fabricating the same	TAKANO, TAMAE

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